Amendment dated October 12, 2006

AMENDMENTS TO THE CLAIMS

Docket No.: 21854-00075-US1

1. (Original)A strain sensor which consists of a polymer that has been irradiated with less

than 1x1015 ions /cm in a portion of its surface with conducting tracks deposited onto the treated

portion to enable the sensor to be connected to an external electric circuit.

2. (Original) A strain sensor as claimed in claim 1 in which the polymer is a polyimide

film.

3. (Original) A method of forming a strain sensor from a polymeric film which includes

the steps of selectively irradiating a surface of the polymer with high energy radiation to change

the composition of the polymer and increase the electrical conductivity in selected portions of the

surface.

4. (Original) A method as claimed in claim 3 in which the high energy radiation

carbonizes the polymer to form conductive particles in the polymer.

5. (Original) A method as claimed in claim 3 in which high energy ions impinge on a

polymer film containing precursor metal compounds, such that decomposition of the precursor

leads to nucleation of conducting metal particles.

6. (Currently amended) A method as claimed in any preceding claim 3 in which the

polymer is a polyimide.

7. (Currently amended) A method as claimed in any preceding claim 3 in which

conducting tracks are deposited onto the treated polymer to enable the device to be connected to

an external electric circuit.

8. (Currently amended) A strain sensor made by the method of any one of claims 3 to 7

claim 3.

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